



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Number 09/681,894
Filing Date 6/21/01
First Named Inventor Joseph R. Chavez
Title Process for improving the radiation hardness of micro circuits
Group Art Unit _____
Examiner Name _____
Attorney Docket No. PRS075

2823
#3/Asm P/A
1/12/02

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

ASSOCIATE POWER OF ATTORNEY

The undersigned, having been appointed attorney in the above-identified application for a United States patent, hereby appoints James M. Skorich, Registration No. 27594 as my associate with full power to prosecute said application, to make alterations and amendments therein, and to transact all business in the Patent Office connected therewith.

All correspondence respecting the aforesaid application should be conducted with my above-named associate attorney at the address of record, namely:

377 ABW/JAN
2251 Maxwell SE
Kirtland AFB, NM 87117

Respectfully submitted,

K E Callahan

Kenneth E. Callahan
Attorney for Applicant(s)
Registration No. 36763
November 28, 2001

RECEIVED
JAN - 2002
C 2000 MAIL ROOM